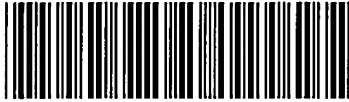


Search Notes

Application No.

10/733,980

Examiner

Victor V Yevsikov

Applicant(s)

HWU ET AL.

Art Unit

2825

SEARCHED

Class	Subclass	Date	Examiner
438	8,16,7 690,691 692	1/22/2005	VY

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
As above		1/22/2005	VY

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
(wafer with plurality with ((chemical mechanical polishing) or CMP) with array) 438/8,16,7,690,691,692.	1/22/2005	VY